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**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1756**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Cathie J. BURKE et al.

Group Art Unit: 1756

Application No.: 10/046,245

Examiner: D. Chacko Davis

Filed: January 16, 2002

Docket No.: 106452

For: **METHODS OF PATTERNING RESISTS AND STRUCTURES INCLUDING THE  
PATTERNED RESISTS**

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the May 5, 2004, 2004 Office Action, please consider the following:

**Amendment to the Claims** are reflected in the listing of claims; and

**Remarks.**

*Please enter  
RD 04/23/04*